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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 2781**

Kazuto HIROKAWA : Docket No. 2003-0954A

Serial No. 10/616,989 : Group Art Unit 3723

Filed July 11, 2003 : Examiner Hadi Shakeri

POLISHING METHOD AND APPARATUS :

THE COMMISSIONER
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement of July 27, 2004, Applicants hereby elect the invention of Group I, claims 1-21, drawn to a polishing method and apparatus, without traverse, for further prosecution.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Kazuto HIROKAWA

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